

# SUPERCONDUCTING RF CAVITY DEVELOPMENT WITH UK **INDUSTRY**

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### Abstract

The aim of the PIPSS project is to develop the capability Electron Beam Welding:of UK industry in the manufacturing of superconducting RF cavities.

#### **Deliverables:-**

- Knowledge transfer Documented process of delivering and testing a cavity
- Cavity should operate at 1.3 GHz, have defined tolerances and a physical length.
- Quench limit of the cavity > 15 MV/m.
- Cavity to have a Q<sub>0</sub> > 1x 10<sup>10</sup> at 2K
- \* The cavity should have no detectable leaks and be able to pump down to a vacuum of 10<sup>-9</sup> Torr

### Cavity Design & Manufacture Cavity Design:-

- Cavity designed based on the TESLA geometry
- > Steps incorporated at the equator and beam-pipe interfaces to ensure easy interlocking and location of adjacent parts
- **Cavity Manufacture:-**
- Successful trials performed with copper
- ⊳ First niobium half cell was distorted
- Dragged due to sheet thickness Second attempt with niobium was successful
- Beam-pipes were spun
- Reduction in wall thickness minimal (~0.75 mm)
- Three sets of cavity parts produced







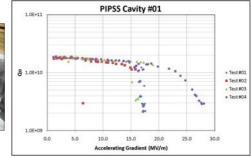


# **Cavity Processing**

- Welding performed at Jefferson Laboratory on their electron beam (EB) welder with 6-axis of freedom
- Cavity #01 and #03 successfully welded
- ≻ Cavity #02 - Final equator weld suffered from a lot of 'flashing'
  - Suspect contamination on the weld surface was trapped in between the two steps at the equator interface
  - Pushed around the weld joint by the electron beam Can result in a puncture due to the build up of the
  - contamination levels
  - A visual examination of the cavity externally and internally indicated that the weld appeared to be leak tight
- ⇒ Future joint designs will incorporate a butt joint

## **RF** Tests

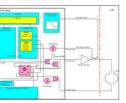
- Cavity #01:-
- Cavity tests performed at Jefferson Laboratory Initial tests the cavity achieved 15.7 MV/m with a Q<sub>0</sub> of
- 1.15 x 1010 at a temperature of 2K.
- Exhibited multipactor at 15.7 MV/m
- CW and pulsed conditioning increased the gradient 17.6 MV/m with a Q<sub>0</sub> of 2.17 x 10<sup>9</sup>. ≻
  - Further processing of the cavity was performed
  - Further BCP etch
  - Vacuum furnace run at 600°C for 10 hours
  - Further high pressure rinses
- > Final tests the cavity achieved 22.94 MV/m with a Qn of 1.06 x 1010 at a temperature of 2K.
- Still exhibiting multipactor at around 16 18 MV/m



#### Cavity #02:-

- Cavity tests performed at Daresbury Laboratory in a newly installed vertical test facility
- The RF system uses a phase lock loop (PLL) system to match the frequency of the RF source to the frequency of the cavity
- Preliminary test results to date are poor
- Strong 'Q-disease' and low field  $\ensuremath{\mathsf{Q}}_{\ensuremath{\mathsf{o}}}$  performance ≻
- Possibly caused by hydrogen in the bulk material Poor temperature control during the BCP process
- Insufficient material was removed
- Cavity to be re-processed and tested





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• T = 2k

5.0

PIPSS Cavity #02 1.0E+08

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1.0E+07 0.0

- Ensures the internal surface is clean prior to a high
- Frequency change is typically 11 kHz/µm



- A BCP etch facility has been developed at Daresbury Laboratory using an existing fume cupboard
- First BCP etch successfully performed on Cavity #02
  - Two etch runs performed 85 um removed



Summary

Cavity #01 exceeded target specification Verification of a purpose built test facility at Daresbury Laboratory was successfully performed

1.0 2.0 3.0 Accelerating Gradient (MV/m)

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Cavity #02 further processing to be performed ⇒ Overall tests performed demonstrate that UK industry has the capability to fabricate SRF components to the required standards



**Buffered Chemical Polishing (BCP):-**

- Acid mixture HF (49%), HNO3 (65%), H3PO4 (85%), 1:1:1 mixture
- BCP etch post welding removes around 100 150 µm of the internal surface of the cavity. Required for:
  - Impurities or inclusions created during manufacture Films produced during the welding process
- BCP etch post vacuum bake (10 hours at 600°C) removes 30µm
- pressure rinsing
- Etch rate is typically 8 µm/min

